IN THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

<u>Listing of Claims</u>:

1. (curren	tly amended)	An x-ray examination apparatus comprising an x-ray source
and an x-ray detector,		
th	e x-ray detector incl	luding having
•a	photoconductor to d	lerive electric charges from incident x-radiation and
re	ad-out elements 🐃	iehthat derive electrical pixel-signals from the electric charges
fromof the photoconductor and		
ar	output circuit to ou	utput the electrical pixel-signal from the read-out elements,
wherein		
a	central group of the	read-out elements is located in a central region of the x-ray
detector and		
a periphe	ral group of the reac	d-out elements is located in a peripheral region which that
surrounds the cer	ntral region,	
the x-ray	examination appara	utus being provided with further having
a selectio	n system to select th	ne central group of read-out elements so as to supply pixel-
signals from the central group of read-elements to the output circuit.		

2. (currently amended) An<u>The</u> x-ray examination apparatus as elaimed in Claimof claim 1, wherein the selection system includes an x-ray shielding member which that shields the peripheral region of the photoconductor from incident x-radiation.

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3. (currently amended) An The x-ray examination apparatus as elaimed in Claim of

claim 1, and further comprising a collimator between the x-ray detector, and the x-ray detector,

wherein the collimator comprises has an x-ray absorbing member which that is spatially registered

with the peripheral region of the photoconductor.

4. (currently amended). An The x-ray examination apparatus as claimed in Claim of

claim 1, wherein and wherein the selection system includes has an encompassing electrode which

surrounds at least substantially surrounding the central region and which is electrically connected to

the read-out elements of the peripheral group.

5. (currently amended) AnThe x-ray examination apparatus as elaimed in Claimof

claim 1, wherein collecting electrodes of read-out elements of the peripheral group are smaller sized

than collecting electrodes of the read-out elements the central group.

6. (currently amended)

An The x-ray examination apparatus as claimed in Claim of

claim 1, wherein the selection system electrically isolates the peripheral group of read-out elements

from the output circuit.

7. (currently amended) An The x-ray examination apparatus as elaimed in Claimof

claim 1, wherein the photoconductor is a continuous semiconductor layer or the photoconductor

includes a plurality of crystalline semiconductor elements.

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8. (currently amended)

An The x-ray examination apparatus as elaimed in Claimof

claim 7, wherein the semiconductor layer or the semiconductor elements contain a photoconducting

material from the group of Cadmium Zinc Telluride, Mercury Iodide or Lead Oxide.